Ref	Hits	Search Query	DBs	Default	Plurals	Time Stamp
#				Operator		•
L1	157	MRAM and (copper with (bitline (bit adj line) (word adj line) wordline (bottom adj electrode)))	US-PGPUB; USPAT	OR	ON	2005/01/02 18:14
L2	179	MRAM and (copper with (bitline (bit adj line) (word adj line) wordline (bottom adj electrode) cap))	US-PGPUB; USPAT	OR	ON	2005/01/02 18:13
L3	0	MRAM and (copper with (((bitline (bit adj line)) and ((word adj line) wordline) and (bottom adj electrode) and cap)))	US-PGPUB; USPAT	OR	ON	2005/01/02 18:12
L4	26	2 and (copper with cap)	US-PGPUB; USPAT	OR	ON	2005/01/02 18:14
S1	264	(jennifer near2 kennedy).xa.	US-PGPUB; USPAT	OR	OFF	2004/12/28 19:16
S2	4	(("6384482") or ("6673675") or ("6174737") or ("6649953")).PN.	US-PGPUB; USPAT	OR	OFF	2004/12/28 19:12
S3	17	S1 and (second near2 planar\$)	US-PGPUB; USPAT	OR	OFF	2004/12/28 19:13
S 4	17	S1 and (second near2 planar\$)	US-PGPUB; USPAT	OR	ON	2004/12/28 19:16
S5	18	S1 and ((two second) near2 planar\$)	US-PGPUB; USPAT	OR	ON	2004/12/28 19:34
S6	1	.S5 not S4	US-PGPUB; USPAT	OR	ON	2004/12/28 19:16
S7	92	S1 and ((two second) near2 steps)	US-PGPUB; USPAT	OR	ON	2004/12/29 12:59
S8	1697	"438"/\$.ccls. and ((two second) near planar\$)	US-PGPUB; USPAT	OR ·	ON	2004/12/28 19:35
S9	168	"438"/\$.ccls. and ((two second) near planar\$ near2 step)	US-PGPUB; USPAT	OR	ON	2004/12/28 19:35
S10	271	"438"/\$.ccls. and ((two second) near2 planar\$ near2 step)	US-PGPUB; USPAT	OR	ON	2004/12/28 19:35
S11	35	S10 and (((chemical\$4 adj mechanic\$4 adj polish\$4) cmp) with ((etch etching etched) adj back))	US-PGPUB; USPAT	OR	ON	2004/12/28 19:37
S12	1910	((two second) near2 steps) with (planar\$)	US-PGPUB; USPAT	OR	ON	2004/12/29 13:00
S13	1483	(438/3).CCLS.	US-PGPUB; USPAT	OR	OFF	2004/12/29 13:43
S14	16	S12 and S13	US-PGPUB; USPAT	OR:	OFF	2004/12/29 13:37
S15	1	("6723655").PN.	US-PGPUB; USPAT	OR	OFF	2004/12/29 13:17

S16	20	("20030148614" "5356833" "5891205" "5934980" "5968710" "5977583" "6069081" "6177320" "6180450" "6200875" "6232228" "6248667" "6271075" "6281541" "6287905" "6319789" "6387759" "6395644" "6431185" "6562651").PN. OR ("6723655").URPN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/12/29 13:24
S17	17	S16 and (CMP)	US-PGPUB; USPAT; USOCR	OR	OFF	2004/12/29 13:36
S18	3	S16 not S17	US-PGPUB; USPAT; USOCR	OR	OFF	2004/12/29 13:36
S19	133	S13 and ((CMP cmping (chemical\$4 adj mechanic\$4 adj polish\$3)) same ((etching etch etched) adj back))	US-PGPUB; USPAT	OR	OFF	2004/12/29 18:08
S20	59	(HONG-LIUBO ZHONG-TOM YANG-LIN).in.	US-PGPUB; USPAT	OR	ON	2004/12/29 13:53
S21	4	S20 and ((CMP cmping (chemical\$4 adj mechanic\$4 adj polish\$3)) or ((etching etch etched) adj back))	US-PGPUB; USPAT	OR	OFF	2004/12/29 13:52
S22	0	S20 and ((MRAM) (FRAM))	US-PGPUB; USPAT	OR	ON	2004/12/29 13:54
S23	28	S20 and (ferroelectric magnetic)	US-PGPUB; USPAT	OR	ON	2004/12/29 13:55
S24	238	(headway adj technolog\$3)	US-PGPUB; USPAT	OR	ON	2004/12/29 13:55
S25	235	(headway adj technolog\$3).as.	US-PGPUB; USPAT	OR	ON	2004/12/29 13:55
S26	50	S25 and (MRAM FRAM ferroelectic CMP cmping)	US-PGPUB; USPAT	OR	ON	2004/12/29 13:56
S27	1483	(438/3).CCLS.	US-PGPUB; USPAT	OR	OFF	2004/12/29 18:09
S28	133	S27 and ((CMP cmping (chemical\$4 adj mechanic\$4 adj polish\$3)) same ((etching etch etched) adj back))	US-PGPUB; USPAT	OR	OFF	2004/12/30 22:59
S29	11	S27 and (dishing dish)	US-PGPUB; USPAT	OR	OFF	2004/12/29 18:13
S30	11	S27 and (dishing dish)	US-PGPUB; USPAT	OR	ON	2004/12/29 18:13
S31	133	S28 not (@ad>"20040519" or @rlad>"20040519")	US-PGPUB; USPAT	OR	ON	2004/12/29 18:18

S32	11	S30 not (@ad>"20040519" or @rlad>"20040519")	US-PGPUB; USPAT	OR	ON	2004/12/29 18:14
S33	33	(US-20020115226-\$ or US-20030148614-\$ or US-20040137646-\$ or US-20040137648-\$ or US-20040191930-\$).did. or (US-5747382-\$ or US-5786259-\$ or US-5934980-\$ or US-5968710-\$ or US-6174737-\$ or US-6177320-\$ or US-625133-\$ or US-6232228-\$ or US-6271124-\$ or US-6281067-\$ or US-6287905-\$ or US-6384482-\$ or US-6391792-\$ or US-6602721-\$ or US-6649953-\$ or US-673655-\$ or US-6730561-\$ or US-6730561-\$ or US-6783999-\$ or US-6790678-\$ or US-6812042-\$).did.	US-PGPUB; USPAT	OR	OFF	2004/12/30 22:59
S34	. 17	S33 and ((CMP cmping (chemical\$4 adj mechanic\$4 adj polish\$3)) same ((etching etch etched) adj back))	US-PGPUB; USPAT	OR	OFF	2004/12/30 23:00